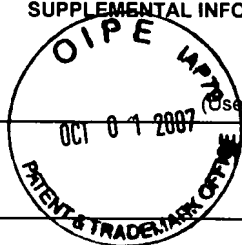


<b>FORM 1449*</b> <b>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT</b> <b>IN AN APPLICATION</b> (Use several sheets if necessary)	Docket Number: GUID.160PA	Application Number: 10/735,519
	Applicant: KIM et al.	
	Filing Date: 12/12/2003	Group Art Unit: 3762



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EXAMINER	DATE CONSIDERED
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